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I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner of Patents and Trademarks, Washington, D.C. 20231, on 8/3/95.

Deborah J. Domme



Docket No. 0756-1363

1/5
F.D. 95
12-6

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT application of:)
Hisashi OHTANI et al.)
Serial No. 08/479,211)
Filed: June 7, 1995)
For: METHOD FOR MANUFACTURING)
SEMICONDUCTOR DEVICE)

INFORMATION DISCLOSURE STATEMENT

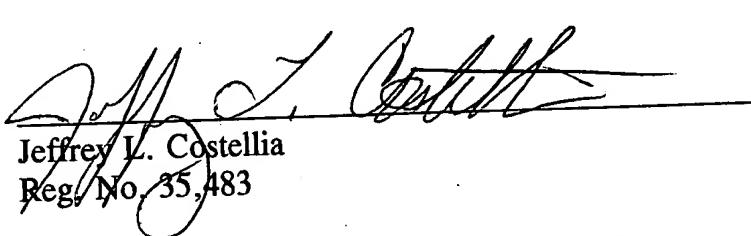
Honorable Commissioner of Patents and Trademarks
Washington, D.C. 20231

Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, it is requested that the references listed on the attached Form PTO-1449 be made of record in the above-identified application.

Copies of the references are submitted herewith in accordance with 37 C.F.R. 1.98(a).

Respectfully submitted,


Jeffrey L. Costellia
Reg. No. 35,483

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Hisashi OHTANI et al.)
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For: METHOD FOR MANUFACTURING)
SEMICONDUCTOR DEVICE)

SUBMISSION OF RELATED APPLICATIONS

Honorable Commissioner of Patents and Trademarks
Washington, D.C. 20231

Sir:

Pursuant to Applicant's duty of candor under 37 C.F.R. §1.56, Applicant wishes to inform the Examiner of the following applications directed to related technical subject matter:

<u>Serial No.</u>	<u>Filing Date</u>	<u>Title</u>
08/160,908 Pat. 5,403,772	12/03/93 Iss. 4/4/95	Method For Manufacturing Semiconductor Device
08/341,106	11/18/94	Semiconductor Device And Method for Manufacturing The Same
08/189,658	02/01/94	Process For Fabricating Semiconductor And



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08/193,748	02/09/94	Process For Fabricating Semiconductor Device Semiconductor Device And Method For Forming The Same
08/196,856	02/15/94	Semiconductor, Semiconductor Device, And Method For Fabricating The Same
08/195,714	02/14/94	Semiconductor And Process For Fabricating The Same
08/195,713	02/14/94	Semiconductor Device And Method Of Fabricating The Same
08/205,111	03/03/94	Transistor And Method For Producing The Same
08/207,182	03/08/94	Transistor And Process For Fabricating The Same
08/207,124	03/08/94	Transistor, Semiconductor Circuit, And Method Of Forming The Same
08/207,173	03/08/94	Semiconductor Device And Process For Fabricating The Same
08/207,126	03/08/94	Method Of Fabricating Semiconductor Device
08/387,238	02/13/95	Method Of Fabricating Semiconductor Device
08/207,185	03/08/94	Semiconductor Circuit And Method Of Fabricating The Same
08/354,502	12/12/94	Semiconductor Circuit And Method Of Fabricating The Same
08/208,880	03/11/94	Semiconductor Device Forming Method
08/216,107	03/21/94	Semiconductor Device/Circuit Having At

		Least Partially Crystallized Semiconductor Layer and Manufacturing Method Thereof
08/411,972	03/28/95	Semiconductor Device/Circuit Having At Least Partially Crystallized Semiconductor Layer and Manufacturing Method Thereof
08/210,764	03/21/94	Transistor And Method Of Forming The Same
08/248,220	05/24/94	Semiconductor Device And Fabrication Method Of The Same
08/248,219	05/24/94	Method For Producing Semiconductor Device
08/248,457	05/24/94	Transistor And Semiconductor Device
08/248,682	05/25/94	Semiconductor Device And Fabrication Method Of The Same
08/248,085	05/24/94	Method For Producing Semiconductor Device
08/255,701	06/07/94	Semiconductor Device
08/258,210	06/10/94	Semiconductor Device And Method For Manufacturing The Same
08/260,413	06/14/94	Semiconductor Device And Method Of Fabricating The Same
08/263,351	06/21/94	Semiconductor Device And Method For Its Preparation
08/277,746	07/20/94	Semiconductor Device And Process For Fabricating The Same

08/286,454	08/05/94	Semiconductor Device And Method Of Manufacturing The Same
08/282,598	07/29/94	Method Of Fabricating Semiconductor Device And Method Of Processing Substrate
08/286,455	08/05/94	Semiconductor Device And Method Of Fabricating Same
08/294,740	08/23/94	Semiconductor Device And Method For Manufacturing The Same
08/329,644	10/25/94	Method For Manufacturing A Semiconductor Device
08/341,935	11/16/94	Method For Manufacturing A Semiconductor Device
08/347,249	11/23/94	A Semiconductor Device And A Method For Manufacturing The Same
08/350,114	11/29/94	Method For Manufacturing A Semiconductor Device
08/347,247	11/23/94	Method For Manufacturing A Semiconductor And An Apparatus For The Same
08/347,250	11/23/94	A Method For Manufacturing A Semiconductor And An Apparatus For The Same
08/356,584	12/15/94	Semiconductor Device And Method For Manufacturing The Same
08/377,938	01/25/95	Method Of Manufacturing A Semiconductor Device
08/391,580	02/21/95	Method For Manufacturing Semiconductor Device
08/430,623	04/28/95	A Method For Manufacturing A Semiconductor Device

08/275,638	07/15/94	Method For Manufacturing a Semiconductor Device
08/360,599	12/21/94	Semiconductor Device and Method for Manufacturing The Same
08/360,600	12/21/94	Transistor and Process For Fabricating the Same
08/430,605	04/28/95	A Semiconductor Device and a Method for Manufacturing the Same
08/439,941	05/12/95	Method for Producing Semiconductor Device
08/439,937	05/12/95	Semiconductor Circuit and Process for Fabricating the Same
08/449,669	05/24/95	Transistor and Process for Fabricating the Same
08/460,210	06/02/95	Semiconductor Device and Method of Fabricating the Same
08/462,770	06/05/95	Semiconductor, Semiconductor Device, and Method for Fabricating the Same
08/462,744	06/05/95	Transistor and Method of Forming the Same
08/462,742	06/05/95	Semiconductor Device and Fabrication Method of the Same
08/462,740	06/05/95	Transistor and Method for Producing the Same
08/462,748	06/05/95	Semiconductor Device and Fabrication Method of the Same
08/467,987	06/06/95	Semiconductor Device Forming Method
08/467,986	06/06/95	Transistor, Semiconductor Circuit, and Method of Forming the Same

08/479,212	06/07/95	A Method for Manufacturing a Semiconductor Device
08/476,511	06/07/95	A Method for Manufacturing a Semiconductor Device
08/481,061	06/07/95	A Method for Manufacturing a Semiconductor Device
08/466,788	06/06/95	Method for Producing Semiconductor Device
08/483,063	06/07/95	Process for Fabricating Semiconductor and Apparatus for Fabricating the Same
08/477,941	06/07/95	Transistor and Process for Fabricating the Same
08/483,047	06/07/95	Method of Manufacturing a Semiconductor Device
08/483,048	06/07/95	Semiconductor Device/ Circuit Having at Least Partially Crystallized Semiconductor Layer and Manufacturing Method Thereof
08/479,719	06/07/95	Method of Manufacturing A Semiconductor Device
08/477,940	06/07/95	Semiconductor Device Forming Method
08/477,943	06/07/95	Method for Producing Semiconductor Device

08/481,062

06/07/95

Semiconductor, Semi-conductor Device and Method for Fabricating The Same

Respectfully submitted,



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